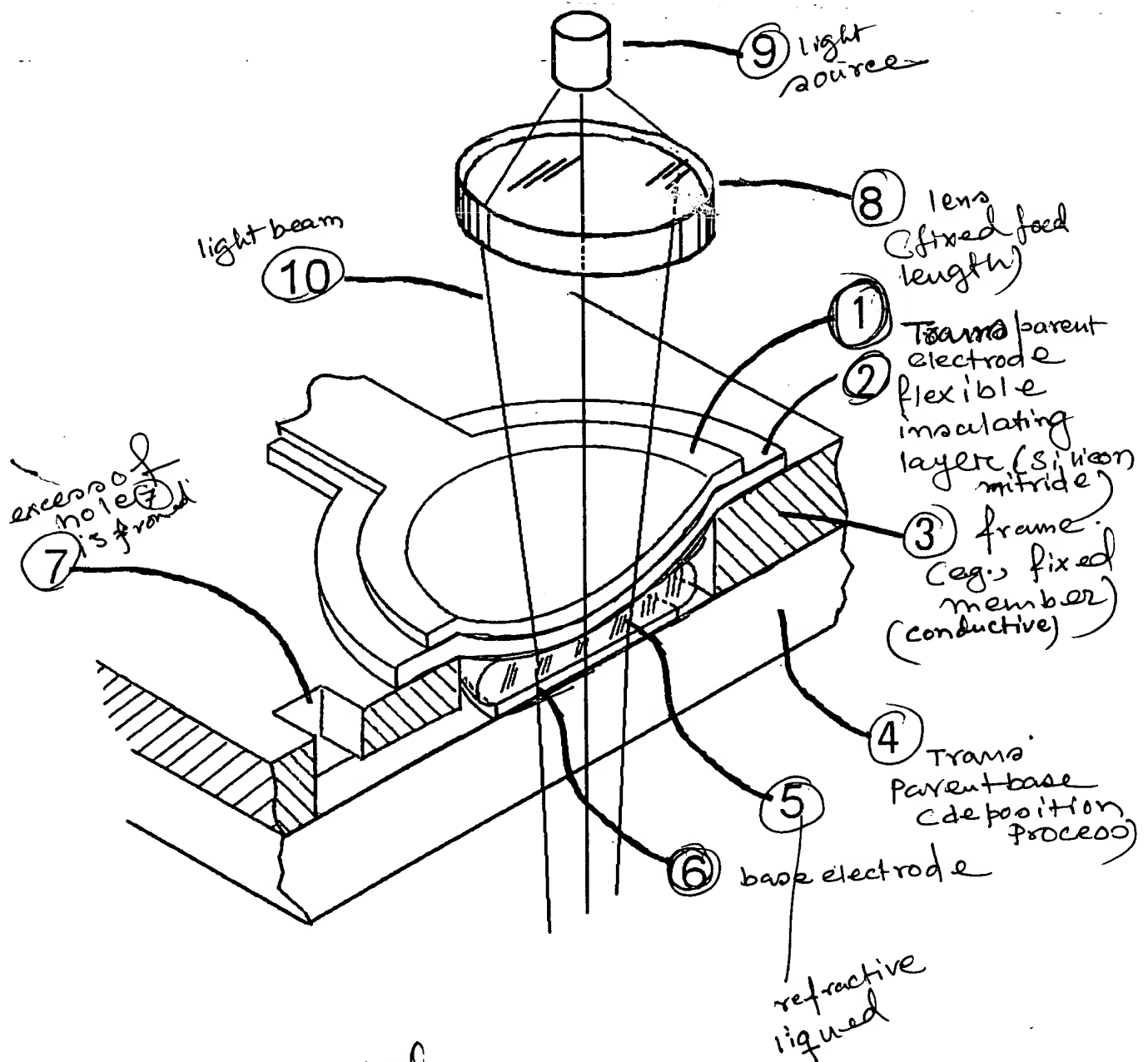


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micro-electromechanical  
micro-mirror device

FIG 1

transparent flat —  
transparent membrane —  
to combine and to create  
adaptive lens.

electrostatic force  
onto silicon substrate —

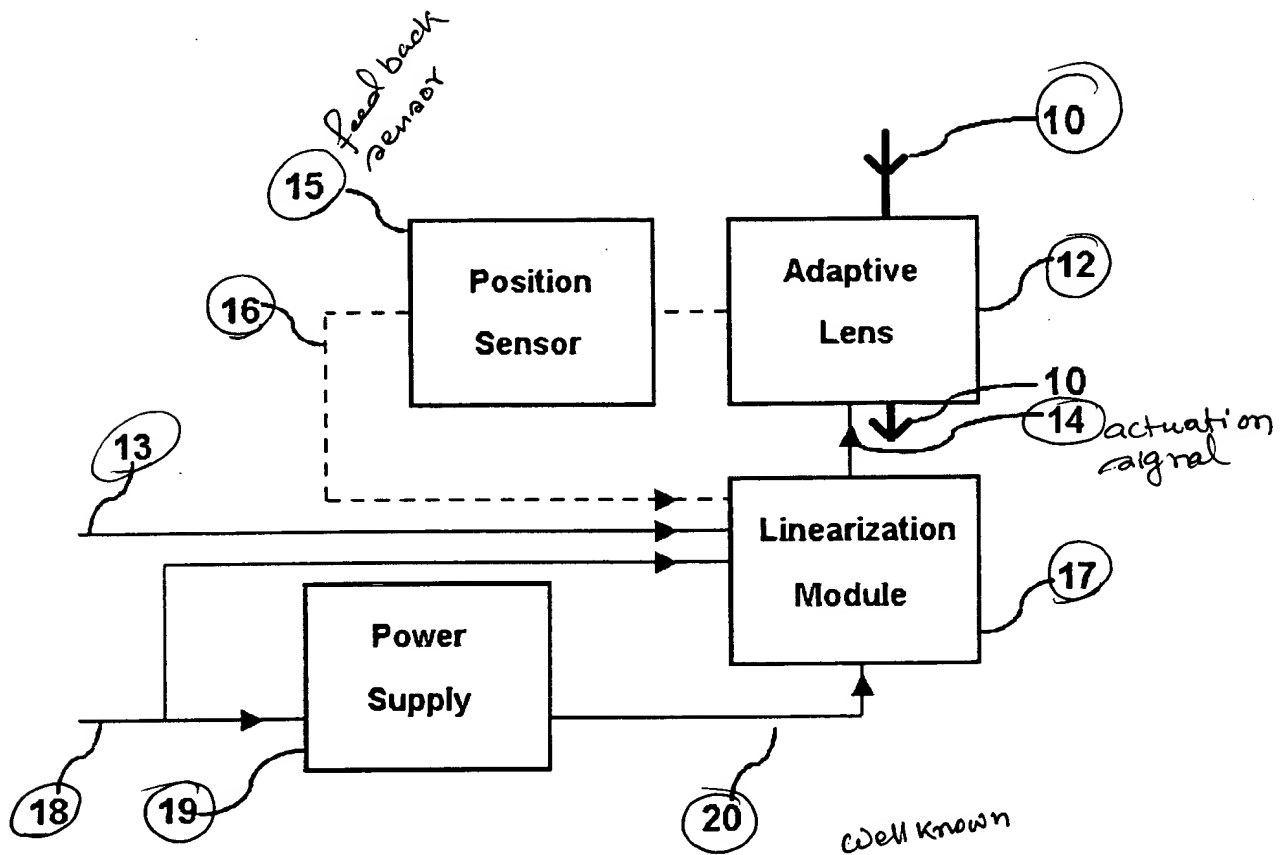
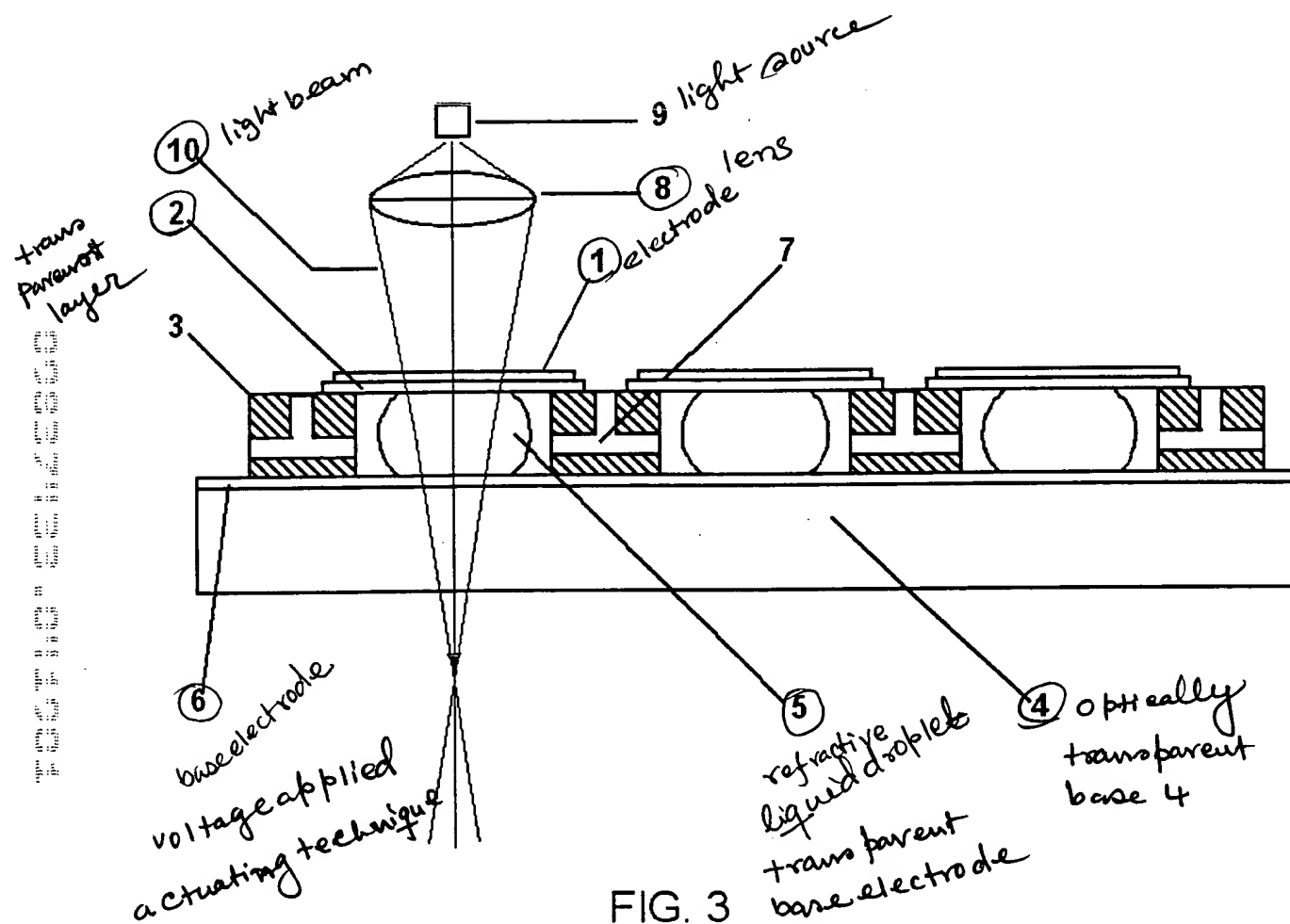


FIG.2



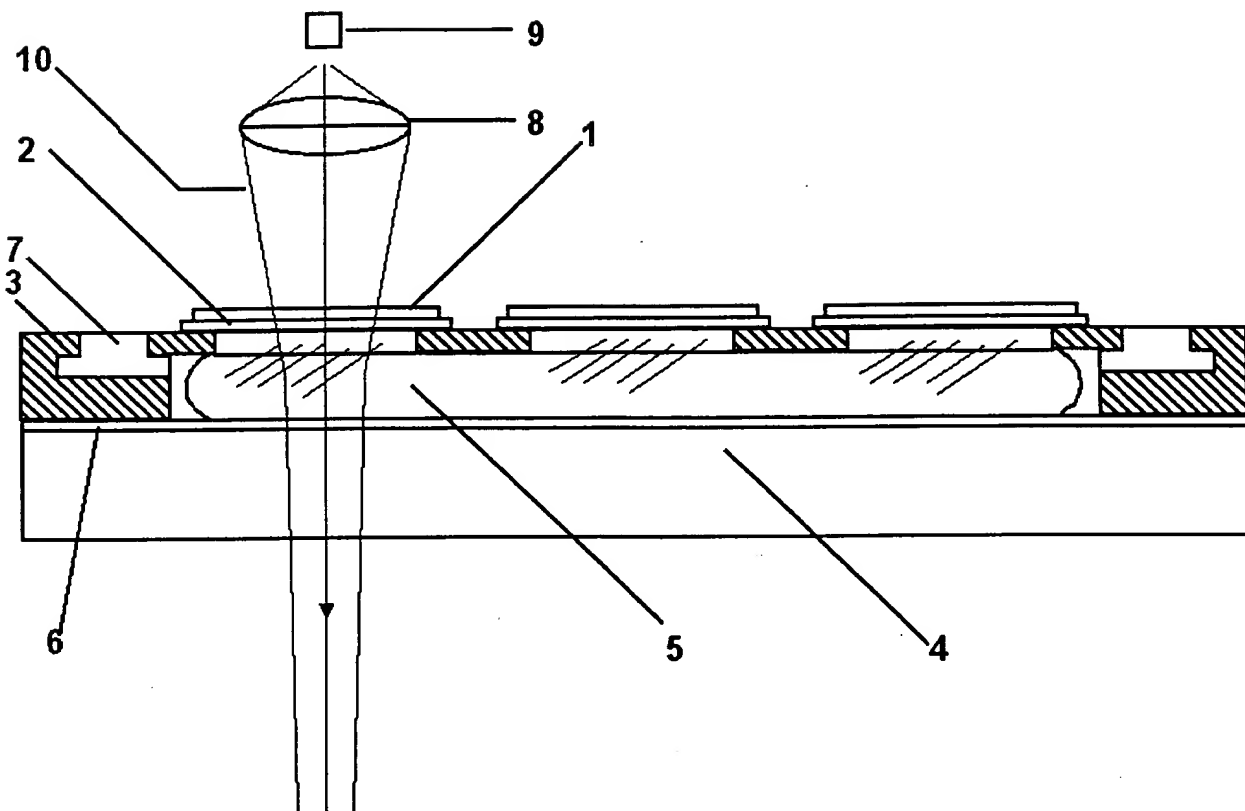


FIG. 4